

Notice of References Cited	Application/Control No. 10/798,001	Applicant(s)/Patent Under Reexamination HATTORI, HIDESHI	
	Examiner Leon Y. Lum	Art Unit 1641	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,468,606	11-1995	Bogart et al.	435/5
	C	US-6,060,237	05-2000	Nygren et al.	435/6
	D	US-6,078,705	06-2000	Neuschafer et al.	385/12
	E	US-6,143,247	11-2000	Sheppard et al.	422/63
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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	U	Hattori, Hideshi. Anti-reflection surface with particle coating deposited by electrostatic attraction. Advanced Materials (2001), vol. 13, no. 1, pp. 51-54.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.